

JC20 Rec'd PTO 27 APR 2005

INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO FORM 1449	Atty. Docket No. 10191/3820	Serial No. To Be Assigned 10/532851
	Applicant(s) CALLIES et al.	
	Filing Date Herewith	Group To Be Assigned

U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>lv</i>	5,744,780*	April 28, 1998	Chang et al.			
<i>M</i>	6,070,813*	June 6, 2000	Durheim			

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
<i>M</i>	199 055 71	Nov. 16, 2000	DE			X**	
<i>M</i>	100 54 853	Aug. 1, 2002	DE			X**	
<i>M</i>	2002 050849	June 4, 2002	JP			X*	
<i>1</i>	199 08 630	Aug. 31, 2000	DE			X*	
<i>M</i>	1 585 609	March 11, 1981	GB			X*	
<i>~</i>	0 299 143	Jan. 18, 1989	EP			X*	

*Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

**Described in specification.

OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.	
	Sun J et al.; INERT GAS BEAM DELIVERY FOR ULTRAFAST LASER MICROMACHINING AT AMBIENT PRESSURE"; Journal of Applied Physics, American Institute of Physics. NY, U.S. Bd. 89, Nr. 12; June 15, 2001.*	
EXAMINER	<i>m Paschuel</i>	DATE CONSIDERED <i>5-13-06</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		